IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of
Kenneth C. Johnson
Application No.: NEW

Filed: HEREWITH

Commissioner for Patents

Alexandria, VA 22313-1450

P.O. Box 1450

For: CD METROLOGY METHOD

Group Art Unit: Unknown

Examiner: Unknown

INFORMATION DISCLOSURE STATEMENT

121 Spear Street, Suite 290 San Francisco, CA 94105 (415) 512-1312

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Label No. EV338308491US in an envelope, addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on January 24, 2004.

STALLMAN & POLLOCK LLP

Dated: 01/24/04

Ву:_____

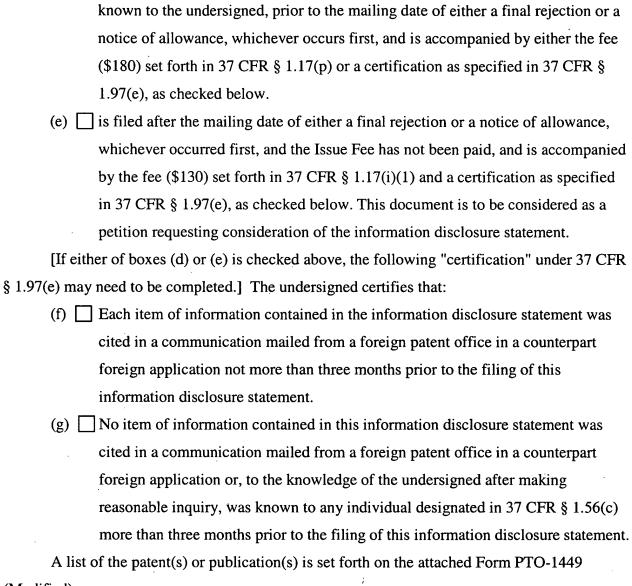
Sir:

Applicant(s) submit(s) herewith patents, publications or other information [attached hereto and listed on the attached Form PTO-1449 (modified)] of which he is aware, which he believe(s) may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

This Information Disclosure Statement:

- (a) accompanies the new patent application submitted herewith. 37 CFR § 1.97(a).
- (b) is filed within three months after the filing date of the application or within three months after the date of entry of the national stage of a PCT application as set forth in 37 CFR § 1.491.
- (c) as far as is known to the undersigned, is filed before the mailing date of a first Office Action on the merits, or before a first office action after filing a Request for Continued Examination under §1.114.
- (d) is filed after the first office action and more than three months after the application's filing date or PCT national stage date of entry filing but, as far as is

Atty Docket No.: TWI-33010



(Modified).

A copy of the items on PTO-1449 (Modified) is supplied herewith, except as noted

A copy of the items on PTO-1449 (Modified) is supplied herewith, except as noted below.

Those patent(s) or publication(s) which are marked with an asterisk (*) in the attached form PTO-1449 (Modified) are not supplied because they are (a) either U.S. Patents and this an application filed after June 30, 2003, or (b) were previously cited by or submitted to the Office in a prior application no. , filed and relied upon in this application for an earlier filing date under 35 U.S.C. § 120.

A concise explanation of relevance of the items listed on form PTO-1449 (Modified) is:

(k) not given

Atty Docket No.: TWI-33010

(l) given for each listed item					
(m) given for only non-English language listed item(s) [Required]					
(n) is in the form of an English language copy of a Search Report from a foreign					
patent office, issued in a counterpart application, which refers to the relevant					
portions of the references [copy attached].					
The Examiner is reminded that a "concise explanation of the relevance" of the submitted					
items "may be nothing more than identification of the particular figure or paragraph of the patent					
or publication which has some relation to the claimed invention," MPEP § 609.					
While the information and references disclosed in this Information Disclosure Statement					
may be "material" pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that					
any patent, publication or other information referred to therein is "prior art" for this invention					
unless specifically designated as such.					
In accordance with 37 CFR § 1.97(g), the filing of this Information Disclosure Statement					
shall not be construed to mean that a search has been made or that no other material information					
as defined in 37 CFR § 1.56(a) exists. It is submitted that the Information Disclosure Statement					
is in compliance with 37 CFR § 1.98 and MPEP § 609 and the Examiner is respectfully					
requested to consider the listed references.					
The Commissioner is hereby authorized to charge our Deposit Account No. 50-1703,					
under Order No. TWI-33010, for any fees required in connection with the filing of this					
Information Disclosure Statement. A duplicate copy of this Notice is enclosed for this					
purpose. In particular, in the event that an Office Action has crossed in the mail with					
this Information Disclosure Statement, the Commissioner is authorized to charge the					
above-named deposit account for any fees required pursuant to CFR §§ 1.17(p) or					
1.17(i)(1).					
Respectfully submitted,					
STALLMAN & POLLOCK LLP					
M					
Dated:					
Michael A. Stallman Reg. No. 29,444					
Attorneys for Applicant(s)					

Atty Docket No.: TWI-33010

INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)

Docket Number (Optional)	Application Number	
TWI-33010	NEW	
Applicant(s)		
Kenneth C. Johnson		
Filing Date	ate Group Art Unit	
Herewith	Unknown	

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	*AA	5,963,329	10/05/99	Conrad et al.	356	372	10/31/97
	*AB	6,268,916	07/31/01	Lee et al.	356	369	05/11/99
	*AC	6,590,656	07/08/03	Xu et al.	356	369	09/21/01
	*AD	5,867,276	02/02/99	McNeil et al.	356	445	03/07/97
	*AE	2001/0051856	12/13/01	Niu et al.	702	57	01/17/01
	*AF	2002/0038196	03/28/02	Johnson et al.	702	179	08/10/01
	*AG	2002/0158193	10/31/02	Sezginer et al.	250	237	02/12/02
	*AH	2003/0147086	08/07/03	Rosencwaig et al.	356	601	09/13/02
	*AI	2003/0204326	10/30/03	Opsal et al.	702	. 28	04/02/03
	*AJ	2003/0076511	04/24/03	Aikens et al.	356	636	05/14/02
							1

FOREIGN PATENT DOCUMENTS

NUMBER WO 03/009063	01/30/03	COUNTRY PCT	CLASS G03F	SUBCLASS 7/20	YES	No v
WO 03/009063	01/30/03	PCT	G03F	7/20		V
			0031	1		1
WO 03/054475	07/03/03	PCT	G01B	11/06		х
WO 02/27288	04/04/02	PCT	G01J	3/28		х
_			· • · · · · · · · · · · · · · · · · · ·			

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

AN	C.J. Raymond, "Scatterometry for Semiconductor Metrology", Handbook of Silicon Semiconductor Metrology, A. Diebold, Ed., New York 2001, Chapter 18, pp. 477-513.

Examiner	Date Considered				
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if					
not in conformance and not considered. Include conv of this form with next communication to applicant.					